

Fig. 4

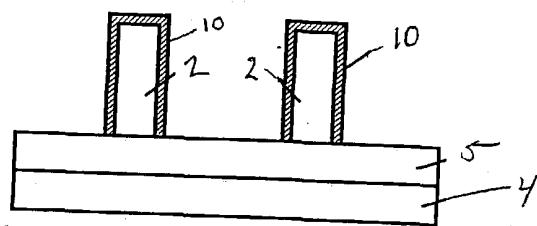


Fig. 5

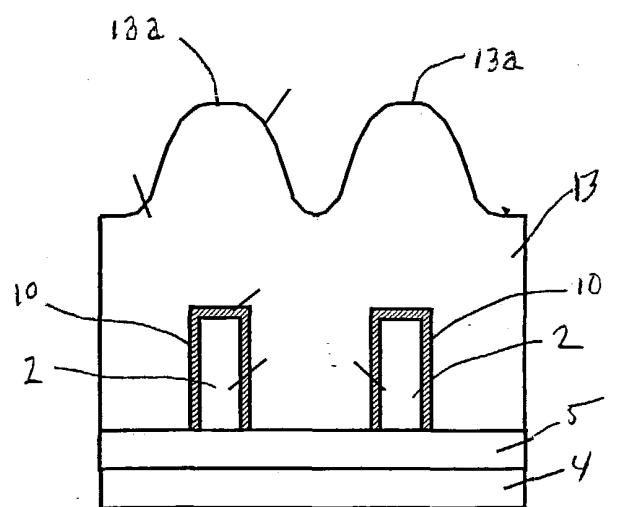
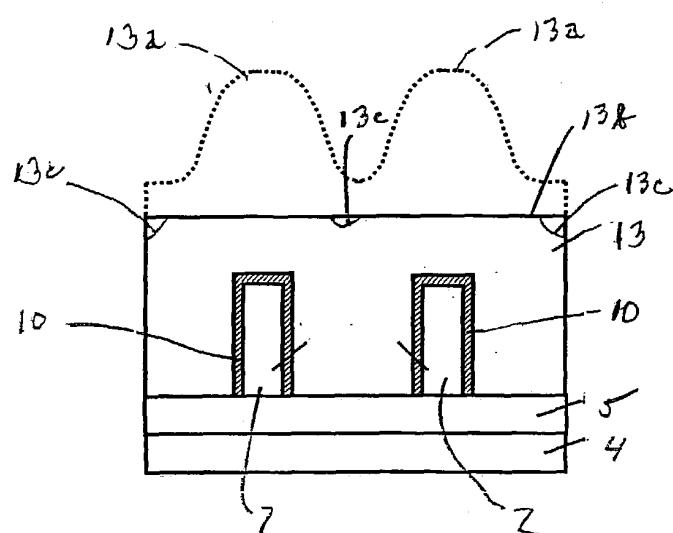


Fig. 6



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